

Title (en)  
Cleaning method for exhaust gas

Title (de)  
Reinigungsverfahren für Abgas

Title (fr)  
Procédé de purification de gaz d'échappement

Publication  
**EP 0687494 A1 19951220 (EN)**

Application  
**EP 95109105 A 19950613**

Priority  
JP 15531694 A 19940613

Abstract (en)  
A cleaning method for an exhaust gas containing ammonia, silanes, and organometallic compounds exhausted from a nitride film production step, etc., for producing compound semiconductors. After removing the silanes and the organometallic compounds from the exhaust gas by contacting the exhaust gas with a cleaning agent comprising soda lime having provided thereon a copper(II) salt, the exhaust gas is contacted with an ammonia decomposition catalyst to decompose ammonia into hydrogen and nitrogen, and undecomposed ammonia in the remaining exhaust gas is then removed by a cleaning agent comprising an inorganic carrier having provided thereon a copper(II) salt, or an active carbon having provided thereon copper sulfate.

IPC 1-7  
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IPC 8 full level  
**B01D 53/46** (2006.01); **B01D 53/72** (2006.01); **B01D 53/75** (2006.01); **B01D 53/86** (2006.01); **B01J 20/06** (2006.01); **C01C 1/12** (2006.01)

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Citation (search report)

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